

Application Serial No. 10/087,510  
Amendment dated April 13, 2004  
Response to Office Action dated January 14, 2004



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/087,510  
Applicants : SETHURAMAN JAYASHANKAR ET AL  
Filed : March 1, 2002  
Title : SINGLE LAYER RESIST LIFT-OFF  
PROCESS AND APPARATUS FOR  
SUBMICRON STRUCTURES

Group Art Unit : 1765  
Examiner : Shamim Ahmed  
Docket No. : 011333

I hereby certify that this  
correspondence is being deposited with  
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Commissioner for Patents, P.O. Box  
1450, Alexandria, Virginia 22313-1450  
on

this 13th day of April, 2004.

*Bea MacDonald*  
Buchanan Ingersoll, P.C.

AMENDMENT

Pittsburgh, Pennsylvania 15219

April 13, 2004

Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

Sir:

In response to Office Action dated January 14, 2004, please amend this application as set forth hereinafter.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.